

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 89518
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Hui-Mei Chen, et al.	:	Confirmation Number: 3341
	:	
Application No.: 10/786,807	:	Group Art Unit: 2822
	:	
Filed: February 25, 2004	:	Examiner: Bac H. Au
	:	
For: METHOD FOR IMPROVING	:	
SEMICONDUCTOR WAFER	:	
TEST ACCURACY	:	

RESPONSE/AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF ELECTRONIC TRANSMISSION
I hereby certify that this correspondence is being electronically-
transmitted to the United States Patent and Trademark Office on
November 20, 2009
/Tobi Terry/

Sir:

In response to the Office Action dated July 21, 2009, please amend the above-identified application as follows:.

Amendments to the Claims are shown in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.